



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/624,340
Confirmation No. 6987
Filing Date July 21, 2003
Inventor Brent A. McClure
Assignee Micron Technology, Inc.
Group Art Unit 2831
Examiner N. Ha
Attorney's Docket No. MI22-2067
Customer No. 021567
Title: Capacitor Constructions and Methods of Forming

INFORMATION DISCLOSURE STATEMENT

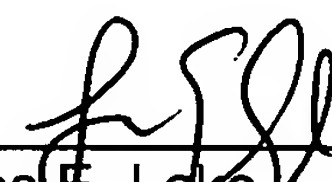
References – See Attached Form PTO-1449

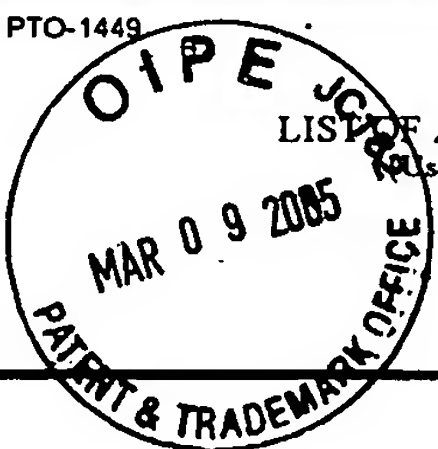
The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449. Pursuant to 37 C.F.R. §1.98(a)(2)(1) no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art references, if any, are attached. No admission is made regarding whether all the submitted references are prior art.

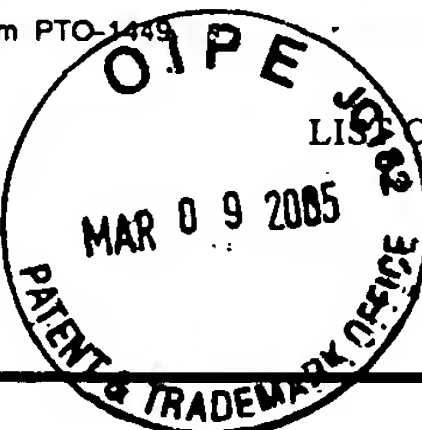
Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated: 09 Mar 2005

By: 
James E. Lake
Reg. No. 44,854

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-2067		SERIAL NO. 10/624,340	
 <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>					APPLICANT Brent A. McClure et al			
					FILING DATE July 21, 2003		GROUP 2831	
U.S. PATENT DOCUMENTS								
*Examiner Initial	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	2002/0142488	10/02	Hong, Suk-Kyoung				
	AB	6,403,156	06/02	Jang				
	AC	6,746,930	6/04	Yang				
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
	AL							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AR		Ritala et al, "Perfectly Conformal TiN and Al2O3 Films Deposited by Atomic Layer Deposition," Chemical Vapor Deposition, v. 5, No. 1, 1999, p. 7-9.					
	AS							
EXAMINER				DATE CONSIDERED				
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>								

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FILING DATE July 21, 2003				GROUP 2831			

U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	09/653,156		Agarwal (as amended 12/2004)			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						

FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
	AQ		
	AR		

EXAMINER	DATE CONSIDERED
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